



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Bernd SZYSZKA et al.

Group Art Unit: 1753

Appln. No. : 10/583,124

Examiner: Rodney G. MCDONALD

I.A. Filed : November 29, 2004

Confirmation No.: 1797

For : METHOD AND DEVICE FOR MAGNETRON SPUTTERING

SUPPLEMENTAL PRELIMINARY AMENDMENT

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Service Window, Mail Stop Amendment
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir:

Prior to the examination of the application, please enter the following amendment.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims begin on page 4 of this paper.

Remarks begin on page 8 of this paper.